

## PATENT NUMBER and ISSUE DATE

## U.S. **UTILITY** Patent Application

<u>.</u>	APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER	7			
	10082567	02 25 2002	438	SUBCLASS	2812		-			
	**APPLICANT	<del>-</del>	<u> </u>	hivona Handi	<u> </u>					
	CONTINUING	G DATA VERIFIED	J:							
	** FOREIGN APPLICATIONS VERIFIED:  PG-PUB DO NOT PUBLISH RESCIND									
	Foreign priority cla 35 USC 119 cond t Verified and Ackno		<b></b> ,€	s ino s ino		ATTORNEY DOCKET NO 1458 TT4763				
	TITLE: Method and system for dose control during an ion implantation process									

NOTICE OF ALL	OWANCE MAILED		CLA	CLAIMS ALLOWED			
	<u></u>	Assistant Examiner	Total Claims	Pri O.	nt Claim for G		
ISSUE FEE				DRAWING			
Amount Due	Date Paid	1	Sheets Drwg.	Figs.Drwg.	Print Fig.		
	<u> </u>	Primary Examine	r				
TEF	RMINAL	PREPARED FOR ISSUE Application Examiner					
DISCLAMER		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					
		FILED WITH:	K (CRF)		CD-ROM		

	DISK	CRF
--	------	-----

(Attached in pocket on right inside flap)